Docket No.: 61282-055 **PATENT**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277

Takeshi KOBAYASHI, et al. : Confirmation Number:

Serial No.: : Group Art Unit:

Filed: January 15, 2004 : Examiner:

For: LEAD FRAME, METHOD OF MANUFACTURING THE SAME, SEMICONDUCTOR

DEVICE USING LEAD FRAME AND METHOD OF MANUFACTURING

SEMICONDUCTOR DEVICE

INFORMATION DISCLOSURE STATEMENT

Mail Stop Patent Application Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In a ccordance with the provisions of 3 7 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

The relevance of each non-English language reference, if any, is discussed in the present specification.

Serial No.:

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

MCDERMQTT, WILL & EMERY

Michael E. Pogarty

Registration No. 36,139

600 13th Street, N.W. Washington, DC 20005-3096 (202) 756-8000 MEF:prg

Facsimile: (202) 756-8087 **Date: January 15, 2004**

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INFORMATION DISCLOSURE CITATION IN AN						ATTY. DOCKET NO. SI 61282-055			SERIAL NO.			
APPLICATION												
						APPLICANT Takeshi KOBAYASHI, et al.						
(PTO-1449)						FILING DATE GRO January 15, 2004			OUP			
U.S. PATENT DOCUMENTS												
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1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.